

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kaiping Liu

Art Unit: 2813

Division of Serial No.: 10/269,226

Examiner: Chandra P. Chaudhari

Filed: Herewith

Docket: TI-34717.1

For: Method to Produce Localized Halo for MOS Transistor

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*Karen Vertz*  
Karen Vertz

*2-24-04*  
Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the examination of the above-identified application, please amend as follows:

**IN THE SPECIFICATION:**

Please amend the Specification by inserting before the first line the following sentence:

--This is a division of Application No. 10/269,226, filed 10/11/2002, the entire disclosure of which is hereby incorporated by reference--.